IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Jingyu Lian, et al.

Art Unit:

2815

Scrial No.:

09/751,551

Examiner:

Ortiz, Edgardo

Filing Date:

December 28, 2000

Docket No.:

00 P 9119 US

For:

MULTI-LAYER Pt ELECTRODE FOR DRAM AND FRAM

WITH HIGH K DIELECTRIC MATERIALS

Commissioner for Patents

FAX RECEIVED

Washington, D.C. 20231

APR 2 2003

TECHNOLOGY CENTER 2800

Preliminary Amendment Accompanying RCE

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Final Office Action mailed on December 2, 2002. These amendments accompany an RCE.. Favorable consideration of the above-referenced patent application are respectfully requested.

Please amend the above-referenced application as described below.

In the Claims:

Please cancel claim 30.

Please amend claims 1, 8 and 28 to read as follows: